



PATENT

67 AF
2811

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Serial No.: 09/881,005
Filed: June 14, 2001
Inventor: Horiuchi et al.
Title: **Multi-Layered Semiconductor
Device and Method for
Producing the Same**
Atty Doc. No.: 149-01
Art Unit: 2811
Examiner: Doug Owens

Certificate of Class Mail

I hereby certify that this correspondence is being deposited with the United States Post Office as "First Class Mail" under 37 C.F.R. §1.8 on the date indicated below and is prepaid in an envelope addressed to: Mail Stop AF
Commissioner for Patents, P.O. Box 1450,
Alexandria, VA 22313-1450 on: August 17, 2004


Dara Salgado

COVER LETTER WITH CERTIFICATE OF FIRST CLASS MAIL

Mail Stop AF
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Enclosed and attached hereto are the following:

- 1) Cover Letter with Certificate of Mailing;
- 2) After Final Amendment; and
- 3) Postcard to be date-stamped and returned.

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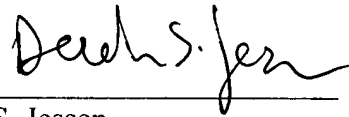
No fees are believed to be required. In the event that an additional fee is required with respect to this communication, the Commissioner is hereby authorized

PATENT

Docket No. 149-01

to charge any additional fees, or credit any overpayment, to Paul & Paul Deposit Account No.16-0750.

Respectfully submitted,

A handwritten signature in black ink, appearing to read "Derek S. Jessen", written over a horizontal line.

Date: August 17, 2004

Derek S. Jessen
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Order No.: 2508